



Attorney Docket No. 0756-2256

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Koichiro TANAKA

Serial No. 09/774,637

Filed: February 1, 2001

For: BEAM HOMOGENIZER, LASER

IRRADIATION APPARATUS,

SEMICONDUCTOR DEVICE, AND

METHOD OF FABRICATING THE

SEMICONDUCTOR DEVICE

) Group Art Unit: 2815

) Examiner: Jose Diaz

) CERTIFICATE OF MAILING

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)

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AMENDMENT UNDER 37 C.F.R. §1.312

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begins on page 2 of this paper.

Remarks begin on page 4 of this paper.